

Electronic Acknowledgement Receipt

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Application Number:	10812747
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Title of Invention:	Silicon substrate etching method and etching apparatus
First Named Inventor:	Kazuo Kasai
Customer Number:	7278
Filer:	James Judge
Filer Authorized By:	
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Power of Attorney	SS002_PwrOfAttny.pdf	299039	no	3

Warnings:	
Information:	
Total Files Size (in bytes):	299039
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